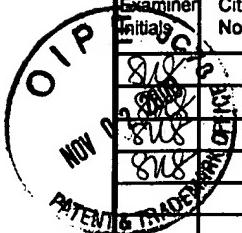


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				Filing Date	May 19, 2000
				First Name Inventor	Michael J. Renn, et al.
				Group Art Unit	Unknown
				Examiner Name	Unknown
Sheet	1	of	1	Attorney Docket Number	66040-9674-01



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Atty. Docket No.: 66040/9674-

Serial No. 09/574,955

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OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

SJL	The American Society for Cell Biology Thirty-Seventh Annual Meeting, Special Poster Session, 11 pages, (December 1997)
SJL	Lewandowski, H.J., et al., "Laser Guiding of Microscopic Particles in Hollow Optical Fibers", <u>Announcer</u> , 27, Summer Meeting-Invited and Contributed Abstracts, pg. 89, (July 1997)
SJL	Renn, M.J., et al., "Evanescent-wave guiding of atoms in hollow optical fibers", <u>Physical Review A</u> , 55(2), pp. 648-652, (February 1996)
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Examiner

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